

L Number	Hits	Search Text	DB	Time stamp
1	145	((amorphous near3 silic\$4) same waveguide) and substrate and ((chemical or vapor) near2 deposit\$5)	USPAT; US-PGPUB; EPO; JPO	2004/04/28 10:51
2	31	((amorphous near3 silic\$4) same waveguide) same ((chemical or vapor) near2 deposit\$5)) and waveguide	USPAT; US-PGPUB; EPO; JPO	2004/04/28 11:23
3	1	5841931.pn.	USPAT; US-PGPUB; EPO; JPO	2004/04/28 11:23
-	14	5150242.pn. or 5134671.pn. or 5228103.pn. or 4571024.pn. or 5862168.pn. or 4685763.pn. or 6003222.pn. or 5657338.pn. or 4787691.pn. or 4886538.pn. or 5838870.pn. or 4997246.pn. or 5841931.pn. or 5757986.pn.	USPAT; US-PGPUB; EPO; JPO	2003/04/30 14:32
-	1	6522799.pn.	USPAT; US-PGPUB; EPO; JPO	2003/05/01 10:13
-	8814	385/14,49,50,88-94,129-132.ccls.	USPAT; US-PGPUB; EPO; JPO	2003/04/30 11:39
-	1	((amorphous near silicon) near waveguide) and (waveguide near6 (substrate or wafer))	USPAT; US-PGPUB; EPO; JPO	2003/10/28 10:24
-	1	385/14,49,50,88-94,129-132.ccls. and (((amorphous near silicon) near waveguide) and (waveguide near6 (substrate or wafer)))	USPAT; US-PGPUB; EPO; JPO	2003/04/30 11:58
-	16	((amorphous near2 silicon) near2 waveguide) and (waveguide near12 (substrate or wafer))	USPAT; US-PGPUB; EPO; JPO	2003/04/30 12:00
-	31	((amorphous near4 silicon) near4 waveguide) and (waveguide near12 (substrate or wafer))	USPAT; US-PGPUB; EPO; JPO	2003/10/09 14:10
-	2	4695122.pn. or 5515460.pn.	USPAT; US-PGPUB; EPO; JPO	2003/04/30 12:57
-	2	(5150242.pn. or 5134671.pn. or 5228103.pn. or 4571024.pn. or 5862168.pn. or 4685763.pn. or 6003222.pn. or 5657338.pn. or 4787691.pn. or 4886538.pn. or 5838870.pn. or 4997246.pn. or 5841931.pn. or 5757986.pn.) and amorphous	USPAT; US-PGPUB; EPO; JPO	2003/04/30 14:44
-	231	385/\$6.ccls. and fiber and waveguide and (oxid\$8 near6 (refract\$6 near2 index))	USPAT; US-PGPUB; EPO; JPO	2003/04/30 15:27
-	17	385/\$6.ccls. and fiber and waveguide and ((oxidation or oxidising or oxidizing or oxidize or oxidise) near6 (refract\$6 near2 index))	USPAT; US-PGPUB; EPO; JPO	2003/04/30 15:38

-	118	385/\$6.ccls. and fiber and waveguide and ((oxidation or oxidising or oxidizing or oxidize or oxidise) same (refract\$6 near2 index))	USPAT; US-PGPUB; EPO; JPO	2003/04/30 15:38
-	47	385/\$6.ccls. and fiber and waveguide and ((oxidation or oxidising or oxidizing or oxidize or oxidise) with (refract\$6 near2 index))	USPAT; US-PGPUB; EPO; JPO	2003/04/30 15:53
-	1	385/\$6.ccls. and fiber and waveguide and ((oxidation or oxidising or oxidizing or oxidize or oxidise) with (refract\$6 near2 index) with (end or tip))	USPAT; US-PGPUB; EPO; JPO	2003/04/30 15:59
-	1	6522799.pn.	USPAT; US-PGPUB; EPO; JPO	2003/05/01 10:13
-	5	((US-6533907-\$).did. or (US-20020159739-\$ or US-20020176467-\$ or US-20020134671-\$ or US-20030002814-\$ or US-20020064360-\$).did.) and ((chemical near vapor near deposition) or CVD)	USPAT; US-PGPUB	2003/10/09 14:03
-	0	5841931.pn. and ((chemical near vapor near deposition) or CVD)	USPAT; US-PGPUB	2003/10/09 14:10
-	53755	385/\$6.ccls. or 65/\$6.ccls.	USPAT; US-PGPUB	2003/10/09 14:09
-	49	((amorphous near6 silicon) near6 waveguide) and (waveguide near15 (substrate or wafer))	USPAT; US-PGPUB; EPO; JPO	2003/10/09 14:10
-	91445	((chemical near vapor near deposition) or CVD or (chemical near vapor))	USPAT; US-PGPUB	2003/10/09 14:11
-	16	(385/\$6.ccls. or 65/\$6.ccls.) and (((amorphous near6 silicon) near6 waveguide) and (waveguide near15 (substrate or wafer))) and (((chemical near vapor near deposition) or CVD or (chemical near vapor)))	USPAT; US-PGPUB	2003/10/09 14:11
-	0	((amorphous near silicon) near waveguide) and ((chemical near vapor near deposit\$6) or CVD)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 10:45
-	0	((amorphous near silicon) near waveguide) and ((chemical near vapour near deposit\$6) or CVD)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 12:10
-	0	"09936775"	USPAT; US-PGPUB; EPO; JPO	2003/10/28 10:46
-	2	4695122.pn. or 5515460.pn.	USPAT; US-PGPUB; EPO; JPO	2003/10/28 10:55
-	0	385/49,50.ccls and (((oxidi\$8 near3 waveguide) near "09/936775" fiber) with (refract\$6 near index)) and (silicon or silica)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 11:19
-	0	385/49,50.ccls and (((oxidi\$8 near3 waveguide) near "09/936775" fiber) with (refract\$6 near index))	USPAT; US-PGPUB; EPO; JPO	2003/10/28 11:19

-	0	385/\$6.ccls and (((oxidi\$8 near3 waveguide) near "09/936775" fiber) with (refract\$6 near index))	USPAT; US-PGPUB; EPO; JPO	2003/10/28 11:19
-	0	385/\$6.ccls and ((oxidi\$8 near3 waveguide) near "09/936775" fiber)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 11:20
-	0	385/\$6.ccls and (((oxidi\$8 near3 waveguide) near "09/936775" fiber) with (refract\$6 near index))	USPAT; US-PGPUB; EPO; JPO	2003/10/28 12:31
-	16094	((oxidi\$8 near3 waveguide) near "09/936775" fiber) with (refract\$6 near index)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 11:21
-	31	(oxidi\$8 near3 waveguide) and (fiber) and (refract\$6 near index)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 11:22
-	0	385/\$6.ccls and ((silicon near waveguide) and ((chemical near vapour near deposit\$6) or CVD))	USPAT; US-PGPUB; EPO; JPO	2003/10/28 12:31
-	0	65/\$6.ccls and ((silicon near waveguide) and ((chemical near vapour near deposit\$6) or CVD))	USPAT; US-PGPUB; EPO; JPO	2003/10/28 12:31
-	197	(silicon near waveguide) and ((chemical near vapour near deposit\$6) or CVD)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:07
-	23	("4978437" "5107538" "5119460" "5206925" "5252194" "5303319" "5381262" "5475528" "5483613" "5555127" "5563979" "5565071" "5603816" "5613995" "5719976" "5831262" "5841931" "5847865" "5855744" "5900057" "5966491" "6080643" "6157765").PN.	USPAT	2003/10/28 13:06
-	735741	"L23" and (amorphous) and silic\$4 and (CVD) or deposi\$6	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:12
-	735739	((("4978437" "5107538" "5119460" "5206925" "5252194" "5303319" "5381262" "5475528" "5483613" "5555127" "5563979" "5565071" "5603816" "5613995" "5719976" "5831262" "5841931" "5847865" "5855744" "5900057" "5966491" "6080643" "6157765").PN.) and (amorphous) and silic\$4 and (CVD) or deposi\$6	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:12

-	6	(("4978437" "5107538" "5119460" "5206925" "5252194" "5303319" "5381262" "5475528" "5483613" "5555127" "5563979" "5565071" "5603816" "5613995" "5719976" "5831262" "5841931" "5847865" "5855744" "5900057" "5966491" "6080643" "6157765").PN.) and (amorphous) and silic\$4 and ((CVD) or deposi\$6)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:42
-	6	(("4978437" "5107538" "5119460" "5206925" "5252194" "5303319" "5381262" "5475528" "5483613" "5555127" "5563979" "5565071" "5603816" "5613995" "5719976" "5831262" "5841931" "5847865" "5855744" "5900057" "5966491" "6080643" "6157765").PN.) and (amorphous) and silic\$4 and ((CVD) or deposi\$6) and (waveguide or optic\$6 or light)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:22
-	2	(("4978437" "5107538" "5119460" "5206925" "5252194" "5303319" "5381262" "5475528" "5483613" "5555127" "5563979" "5565071" "5603816" "5613995" "5719976" "5831262" "5841931" "5847865" "5855744" "5900057" "5966491" "6080643" "6157765").PN.) and (amorphous) and silic\$4 and ((CVD) or (chemical near2 deposi\$6)) and (waveguide or optic\$6 or light)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:23
-	1	(("4978437" "5107538" "5119460" "5206925" "5252194" "5303319" "5381262" "5475528" "5483613" "5555127" "5563979" "5565071" "5603816" "5613995" "5719976" "5831262" "5841931" "5847865" "5855744" "5900057" "5966491" "6080643" "6157765").PN.) and (amorphous) and silic\$4 and ((CVD) or (chemical near2 deposi\$6)) and waveguide	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:23
-	4	(("4978437" "5107538" "5119460" "5206925" "5252194" "5303319" "5381262" "5475528" "5483613" "5555127" "5563979" "5565071" "5603816" "5613995" "5719976" "5831262" "5841931" "5847865" "5855744" "5900057" "5966491" "6080643" "6157765").PN.) and (amorphous near3 silic\$4)	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:42

-	2	(("4978437" "5107538" "5119460" "5206925" "5252194" "5303319" "5381262" "5475528" "5483613" "5555127" "5563979" "5565071" "5603816" "5613995" "5719976" "5831262" "5841931" "5847865" "5855744" "5900057" "5966491" "6080643" "6157765").PN.) and (amorphous near3 silic\$4) and waveguide	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:43
-	1301	(amorphous near3 silic\$4) and waveguide	USPAT; US-PGPUB; EPO; JPO	2003/10/28 13:44
-	257	(385/\$6.ccls.) and (amorphous near3 silic\$4) and waveguide	USPAT; US-PGPUB; EPO; JPO	2004/04/12 11:54
-	243	(385/\$6.ccls.) and (amorphous near3 silic\$4) and waveguide and substrate	USPAT; US-PGPUB; EPO; JPO	2004/04/12 11:54
-	1029	(amorphous near3 silic\$4) and waveguide and substrate and deposition	USPAT; US-PGPUB; EPO; JPO	2004/04/12 11:55
-	492	((amorphous near3 silic\$4) same deposition) and waveguide and substrate	USPAT; US-PGPUB; EPO; JPO	2004/04/12 11:56
-	67	((amorphous near3 silic\$4) same deposition) same waveguide) and substrate	USPAT; US-PGPUB; EPO; JPO	2004/04/28 10:50